



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Sunji ICHIKAWA

Serial No. NEW

Filed January 26, 2004

COPY

Attn: APPLICATION BRANCH

Attorney Docket No. 2004-0095A

LEAD FRAME, MANUFACTURING
METHOD OF THE SAME, AND
SEMICONDUCTOR DEVICE USING THE
SAME

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant in the above-entitled application hereby claims the date of priority under the International Convention of Japanese Patent Application No. 314581/2003, filed September 5, 2003, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is submitted herewith.

Respectfully submitted,

Sunji ICHIKAWA

By

Nils E. Pedersen
Registration No. 33,145
Attorney for Applicant

Nils E. Pedersen
Reg. No. 54,574

NEP/krq
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
January 26, 2004